Angular Orientation-Specific Directed Self-assembly and Integration of Ultra Small Dies

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ABSTRACT

We report on recent progress in the directed self-assembly of discrete inorganic semiconductor device components. Different from prior research, the goal is to enable the integration of increasingly small dies while supporting unique-angle orientation and contact pad registration. The process is based on the reduction of surface free energy between liquid solder coated areas on the substrate and metal-coated binding sites on the semiconductor dies. Recent advances include flip-chip assembly with unique angular orientation accomplished using “two-element” docking sites that contain pedestals that act as chaperones for the solder directed assembly to take place. The scale reduction to 20 µm sized components involves the use of a liquid-liquid interface to concentrate component delivery and speed up the self-assembly process to prevent oxidative dissolution of the solder sites prior to completion.

Keywords: fluidic self-assembly, chips, dies, flip-chip assembly, solder directed heterogeneous integration, non-robotic assembly, engineered self-assembly.

The construction of man-made artifacts such as cell phones and computers relies on robotic assembly lines that place, package, and interconnect a variety of devices that have macroscopic (>1 mm) dimensions [1]. The key to the realization of these systems is our ability to integrate/assemble components in 2D/3D as well as link/interconnect the components to transport materials, energy, and information. The majority of these systems that are on the market today are heterogeneous in nature. Heterogeneous systems can be characterized as systems that contain at least two separate parts, thereby prohibiting monolithic integration. Such systems are typically fabricated using robotic pick and place. The size of the existing systems could be reduced by orders of magnitudes if microscopic building blocks could be assembled and interconnected effectively [2]. The difficulty is not the fabrication of smaller parts, but their assembly into an interconnected system. For components with dimensions less than 100 µm, adhesive capillary forces often dominate gravitational forces, making it difficult to release the components from a robotic manipulator [3]. As a direct result, heterogeneous integration using an extension of serial robotic pick and place and wirebonding has not proven a viable solution.

At the other extreme, nature forms materials, structures, and living systems by self-assembly on a molecular length scale [4, 5]. As a result, self-assembly based fabrication strategies are widely recognized as inevitable tools in nanotechnology and an increasing number of studies are being carried out to “scale-up” these concepts to close the assembly gap between nanoscopic and macroscopic systems. Recent demonstrations of processes that can assemble micrometer to millimeter-sized components include: shape-directed fluidic methods that assembly trapezoidal parts on planar surfaces on the basis of gravity and complementary 3D shapes [6, 7], liquid-solder-based self-assembly that uses the surface tension between pairs of molten solder drops to assemble functional systems [8-10], capillary force-directed self-assembly that uses hydrophilic/hydrophobic surface patterns and photocurable polymers to integrate micro-optical components, micromirrors and semiconductor chips on silicon substrates [11-13], and sequential shape-and-solder-directed self-assembly that combines 3D shapes to define a chaperone with solder directed assembly to effectively assemble electrically interconnected parts [14-19]. The sequential shape-and-solder-directed self-assembly process has been applied to flip-chip assembly with unique contact pad registration [16] as well as the packaging of light emitting diodes [14-16] and transponders that can be interrogated remotely [17]. Comparing more recent concepts [18, 19] with the pioneering work by Yeh and Smith [6, 7], there are a number of fundamental differences: Recent methods do not require trapezoidal chips to prevent upside down assembly and asymmetric L or T shaped chip designs for angular orientation control. Instead they use simple shapes or openings in combination with solder coated areas to enable assembly in 3D or in 2D considering flip-chip assembly with unique angular orientation and contact pad registration. The openings are bigger than the components and act as guides or chaperones for the solder directed self-assembly process. The solder drives the assembly into the aligned stable position and the driving force is surface tension, as opposed to gravity. Recent studies have also overcome the difficulty in assembling more than one component type through sequential methods that either use activation of selected receptors [20-22] or different sized openings [14-16]. Unique orientation no longer requires asymmetric three dimensional chips including triangular, L or T shaped parts that are not very common. While a number of applications have been demonstrated, scalability to smaller dimensions remains a challenge. Stauth et al. has successfully tested shape and solder directed self-assembly with 100 µm sized components [23], which are three times
smaller than our previously reported parts [16]. This paper extends prior work [10, 14-16] in the area of shape and solder directed self-assembly to smaller scales. It reports on angular orientation control, flip-chip assembly, and recent progress in the assembly of ultra small chiplets with a side length of 20 µm. A new system employing a liquid-liquid interface will be presented to deliver and concentrate components with correct pre-orientation.

Figure 1: Self-assembly of dies using A) solder-based alignment alone, B) wells for size discrimination, and C) combined pedestals - solder -, and IO - layouts that supports single angular orientation and flip-chip contact pad registration.

Figure 1 Illustrates the basic concept of solder directed self-assembly introducing alignment pedestals and contact pad layouts with increasing complexity. The layout B prevents assembly of more than one component type onto a single receptor, while the layout in C enables flip-chip assembly with single angular orientation and contact pad registration forming multiple contacts to the device; components can only attach to the solder-coated areas if a correct angular pre-orientation condition is met: components that arrive at the docking sites with an angular orientation that deviates by more than ±90° from the desired orientation will not find a sufficient overlap between the binding site (contact area) on the components and the solder-coated areas and will not attach. Other components will be captured and align due to the reduction of the interfacial free energy.

Figure 2 shows the sequential self-assembly procedure that we employ to batch-assemble different sized components with a single-angle orientation. The assembly was performed in a glass vial that was filled with ethylene glycol at a temperature of 150 °C so the solder was molten. Ethylene glycol was used to accommodate the higher melting point solder that is not compatible with a water-based assembly solution. We used both a low- (47 °C) and medium- (138 °C) melting-point (mp) solders (Y-LMA-117 and LMA-281, Small Parts, Miami Lakes, FL) in our experiments; we did not observe a notable difference between the two. The ethylene glycol solution was made slightly acidic (pH ~4.0) with hydrochloric acid to remove metal oxide from the surface of the solder drop; an oxide layer that — if sufficiently thick — blocked the wetting of the metal surface.

Component transport and mixing was provided by hand agitation of the vial/drum to accomplish a tumbling motion across the surface, a motion that needs to be automated in future work.

Figure 2: Rotational agitation procedure showing a two-step process to integrate multiple types of chiplets on a single substrate.

Through the course of this study we tested a number of different components including GaAlAs-LEDs, Si, glass, and SU-8 blocks with different pad layouts. Fig. 3 represents a summary of the results. Fig. 3A illustrates 1500 silicon chiplets, 300 µm on a side, which assembled onto a flexible polyimide surface with 98% coverage. With ~5000 components inside the vials, the assembly took about 90 s to reach steady state and was completed in 3 minutes. The lateral and angular precision was ~15 µm and ~3°, respectively, and limited by non-uniformity of the components that were fabricated by dicing using a dicing saw. Fig. 3B shows GaAs/GaAlAs light-emitting diodes that have been assembled on a silicon substrate. The insets show the LEDs under operation. A potential problem that we have observed is highlighted in the inset (Fig. 5A). Without alignment pedestals, two chiplets can occupy a single receptor which is considered a defect. This defect can be eliminated using alignment pedestals as illustrated in figure 3C. The entire assembly contained 196 interconnected LEDs with a side length of 280 µm. The chiplets assembled with four stable orientations 0°, 90°, 180°, and 270°. It is possible to remove undesired orientations and achieve flip chip assembly with unique orientation. Fig. 3D shows the result of assembling silicon components that carried alignment marks on the topside into two-element docking sites. All of the components assembled with unique angular orientation and contact pad registration with an angular standard deviation <0.3°. The alignment pedestals were fabricated using SU-8 in this example and were 100 µm tall.
components were $2 \times 1 \times 1$ mm glass blocks. The blocks assembled with unique orientation and attached to 7 contacts on the substrate that are visible from the top. The smallest components were 280 µm on a side (Fig. 3C).

Solder directed self-assembly can be scaled down to much smaller dimensions than what has been demonstrated. The surface free energy of liquid solder dominates thermal energy and Brownian motion down to the sub-1 µm scale. In practice, however, scaling has been challenging. The problem is a surface oxide that forms due to residual oxygen, blocking the self-assembly. To combat this problem, small amounts of acid are added (pH 2-4) to the assembly solution. The acid, however, leads to an oxidative dissolution of the solder an issue which becomes increasingly challenging as the solder volume is reduced. There are a number of potential solutions to this problem. In this study we present a new component delivery mechanism to speed up the self-assembly process by concentrating the number of available components. The process is illustrated in Figure 4.

Figure 3: Summary of self-assembly results using GaAlAs-LEDs, Si, Glass, and SU-8 blocks with varying docking site layouts including solder-directed assembly of A) silicon parts and B) LEDs, C) well assembly, D) single-angle orientation assembly using “two-step” docking sites, E) contact pad, two step registration, and F) flip-chip assembly of parts with multiple IO connections.

Fig. 3E is an example of sequential batch transfer showing a 10×10 array that contains 900 µm and 500 µm sized dies assembled using a two-step self-assembly sequence. The largest

Figure 4: Self-assembly of ultra-small components using a liquid-liquid interface to increase the concentration of components that are available for assembly. A) Diagram showing the substrate being pushed through a silicone oil - water interface and resultant SEM images B) and C).

The components are injected into the silicon oil and settle at the oil/water interface. We tested SU-8 and Si blocks that were formed through etching carrying a single gold contact on one side. The components were plasma treated in an oxygen plasma prior to use and settled at the oil - water interface with the gold surface facing the oil
phase and the remainder facing the water. There has been a substantial body of work on self-assembly at the liquid-liquid interface that used the static wetting angle between components. The illustrated concept does not depend on or use the static wetting angle. Instead it makes use of the dynamic angle for a given liquid – liquid solid interface. The sheer velocity and viscosities determine the shape of the interface. Both up and downward slopes are possible. When the substrate is immersed into the liquid, the angle changes dramatically and components are delivered and concentrated in a thin surface layer. Downward motion results in rapidly accelerated self-assembly. Scaling down to 10-fold smaller chip dimensions, however, was not possible by a linear extension of the previous agitation concepts. Instead a new concept has been developed that makes use of a dynamic method that immerses the chip through a liquid-liquid interface. While the feasibility has been tested with 20 µm sized dies, we have not yet established the ultimate complexity in terms of alignment accuracy, number of contacts, and density of interconnects that could be established by this process. A rough estimate of the alignment accuracy for the smallest dies is 1-2 µm.

REFERENCES


In summary, we have demonstrated the directed self-assembly of micrometer-sized components with single-angular orientation accuracy of 0.3° and contact-pad registration for 280µm – 2mm sized dies. Alignment pedestals and registration to 7 contact pads has been shown providing a route to flip-chip assembly of micrometer-sized components with single-angular orientation accuracy, number of contacts, and density of interconnects that could be established by this process. A rough estimate of the alignment accuracy for the smallest dies is 1-2 µm.

Figure 5: Observed defects resulting from ultra-small fluidic self-assembly: A) More than one component per receptor site, and B) flawed orientation.